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<b>APPLICANTS</b> Hiroyuki Ito, Narita-shi, JAPAN;				
<b>** CONTINUING DATA *****</b> <i>MNU</i>				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN P2002-206038 07/15/2002				
<b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> ** 10/15/2003				
Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWING 4	TOTAL CLAIMS 9
Verified and Acknowledged Examiner's Signature	Initials	INDEPENDENT CLAIMS 1		
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<b>TITLE</b> Ion implantation method and method for manufacturing SOI wafer				
FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		